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Docket No.: SON-2010
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Hisao Hayashi et al.

Application No.: 09/772,986

Confirmation No.: 2637

Filed: January 31, 2001

Art Unit: 2811

For: THIN FILM SEMICONDUCTOR DEVICE
AND MANUFACTURING METHOD
THEREOF

Examiner: T. F. Tran

RESPONSE TO FINAL ACTION UNDER 37 C.F.R. 1.116

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

This is in response to the Office Action dated November 28, 2007.

Remarks/Arguments begin on page 2 of this paper.